ASMINT.002C3

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant

Granneman et al.

App. No.

Unknown

Filed

Herewith

For

METHOD AND APPARATUS FOR SUPPORTING A SEMICONDUCTOR WAFER DURING PROCESSING

Examiner

Unknown

Group Art Unit

Unknown

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Enclosed is form PTO-1449 listing 51 references, 13 of which are enclosed, and 38 of which are not enclosed pursuant to 37 CFR § 1.98(d) as they were either cited by or provided to the Patent Office in parent application No. 09/717,702, filed November 20, 2000, from which priority is claimed. This Information Disclosure Statement is being filed within three months of the filing date of this application or upon filing if this is a CPA or RCE, and no fee is required in accordance with 37 C.F.R. § 1.97(b)(1), (b)(2), or (b)(4).

Respectfully submitted,

KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: June 24,2003

Adeel S. Akhtar

Registration No. 41,394

Attorney of Record

Customer No. 20,995

(415) 954-4114

FORM	PTO	-1449
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U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(USE SEVERAL SHEETS IF NECESSARY)

APPLICANT Granneman et al.	
FILING DATE	GROUP

U.S. PATENT DOCUMENTS						
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	3,947,236	3/30/76	Lasch, Jr.	T.		
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		APPLICANT .	APPLICANT Granneman et al.	·	
	(USE SEVERAL	SHEETS IF NECESSARY)	FILING DATE	GROUP	

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*EXAMINER: INITIAL IF CITATION CONSIDERED, WHETHER OR NOT CITATION IS IN CONFORMANCE WITH MPEP 609; DRAW LINE THROUGH CITATION IF NOT IN CONFORMANCE AND NOT CONSIDERED, INCLUDE COPY OF THIS FORM WITH NEXT COMMUNICATION TO APPLICANT.

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